

Art Unit: "Unassigned

Examiner: Unassigned

Atty. Docket: N45-160780M/FK

re application of:

Keisuke BAN, et al.

Application No.: 10/630,873

Filed: July 31, 2003

For: REDUCTION CASTING METHOD, REDUCTION CASTING APPARATUS AND MOLDING DIE USING SAME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Under the provisions of 37 CFR §1.97 through §1.99 and pursuant to applicant's duty of disclosure under 37 CFR §1.56, applicant respectfully brings the following document, listed on the attached form PTO-1449, to the attention of the Examiner in charge of the above-identified application. A copy of the listed foreign document is enclosed herewith for the convenience of the Examiner.

This citation does not constitute an admission that the reference is relevant or material to the claims. It is only cited as constituting related art of which the applicant is aware.

It is respectfully requested that the listed reference be considered by the Examiner and formally made of record in this application.

Please charge any deficiencies in fees and credit any overpayment of fees to attorney's deposit account no. 23-1951 (McGuireWoods LLP).

Respectfully submitted,

Registration No.: 38,093

McGuireWoods LLP 1750 Tysons Boulevard, Suite 1800 McLean, VA 22102 (703)712-5000

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Form PTO-1449 (Modified)			Attorney Docket No.: N45-160780M/FK			Serial No.: 10/630,873			
LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S App				Applicant: Leisuke BAN, et al.					
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EXAMINER				DATE CONSIDERED					
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applicant.									